

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Patricia B. SMITH et al. Confirmation No.: 3087
Application Number : 10/647,985
Filed : August 26, 2003
Title : POST-ETCH CLEAN PROCESS FOR POROUS LOW
DIELECTRIC CONSTANT MATERIALS
TC/Art Unit : 1746
Examiner: : Zeinab El Arini

Docket No. : TI-33260 (0025.0184)
Customer No. : **23494**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a one month extension of time to reply to the Office
Action of June 28, 2007. A fee of \$120.00 is enclosed.

Please grant any extensions of time required to enter this response and charge
any additional required fees to Texas Instruments' deposit account 20-0668.

Respectfully submitted,

Dated: October 26, 2007

By: 

Timothy M. Hsieh
Reg. No. 42,672